



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **MAIL STOP: RCE**
Akihisa HONGO et al. : Docket No. 2001_0133A
Serial No. 09/762,582 : Group Art Unit 1753
Filed April 12, 2001 : Examiner Brian Mutschler

SUBSTRATE PLATING **Confirmation No. 5731**
METHOD AND APPARATUS

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

In response to the Office Action of October 27, 2004, the period for response to which
having been extended by three months to April 27, 2005, please amend the above-identified U.S.
Patent application as follows: